

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Hidemi Takasu

Serial No .:

09/212,915

Examiner: M. Estrada

Filed

December 16, 1998

Group Art Unit: 2823

For

PROCESS FOR FABRICATING A

SEMICONDUCTOR DRIVE

AMENDMENT

I hereby certify that this paper is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Box AF, P.O. Box 1450, Alexandria, VA 22313-1450, on:

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Date of Deposit

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Alexandria, VA 22313-1450

Sir:

May 19, 2003
Date of Signature ECHNOLOGY CENTER 2800

In response to the Examiner's Action mailed November 18, 2002 please amend the above-identified application as follows:

In the Claims:

Please amend claim 1 in the following manner:

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